

### 3.15

#### Photoconductors, Photovoltaics and Photodetectors

C.A. Ross, Department of Materials Science and Engineering

Reference: Pierret, chapter 9.2 and 9.3

Photoconductors – conductivity a function of light

Photovoltaics – generate power from light

Photodetectors – use a pn junction to detect light

Photoconducting materials:

CdS, ZnS for camera lightmeters, amorphous As, Se, Te for photocopiers

Photodiode and Photovoltaic (PV):

Carriers created within  $L_n$  or  $L_p$  of junction contribute to reverse current:

$$I = I_o + I_G$$

Photodiode operates in reverse bias. A PIN diode has a wide depletion region; operates much faster than a pn junction photodetector because it doesn't rely on diffusion.

A PV operates in the fourth quadrant (positive V, negative I). When connected to a load (e.g. a battery charger or a lightbulb) with resistance  $R_L$ ,

$$V = I (R_{PV} + R_L)$$

$$\text{also } I = I_o (\exp(eV/kT) - 1) + I_G$$

these two relations define the voltage and current that the PV produces.

$$\text{Power} = IV$$

Solar Cells: the PV must respond to the visible spectrum (400 – 700 nm, or 2 – 3 eV; note that  $\lambda (\text{nm}) = 1.24/E (\text{eV})$ )

Ideally we would use a bandgap of about 1.2 eV, but Si does not absorb light well because it has an indirect band gap.

Direct and indirect gap

$$\text{On an E-k plot: } m^* = \hbar^2 (\partial^2 E / \partial k^2)^{-1}$$

$$\text{Momentum of an electron typically } \hbar/a \sim 10^{10} \text{ m}^{-1}$$

$$\text{Momentum of a photon} = 2\pi/\lambda \sim 10^7 \text{ m}^{-1}$$

If the band gap is indirect, a phonon plus a photon are needed to make an e-h pair, so light absorption (and emission) is less efficient.

Amorphous Si: uncertainly principle  $\Delta x \Delta p \geq \hbar$

-the localization of carriers gives them an uncertain momentum, so direct absorption of light can occur. Use PIN design because mobility is low.

Scanned article removed due to copyright restrictions.

Please See "This Month in Physics History, October 22, 1938: Invention of Xerography." *APS News* 12 (2003): 2.

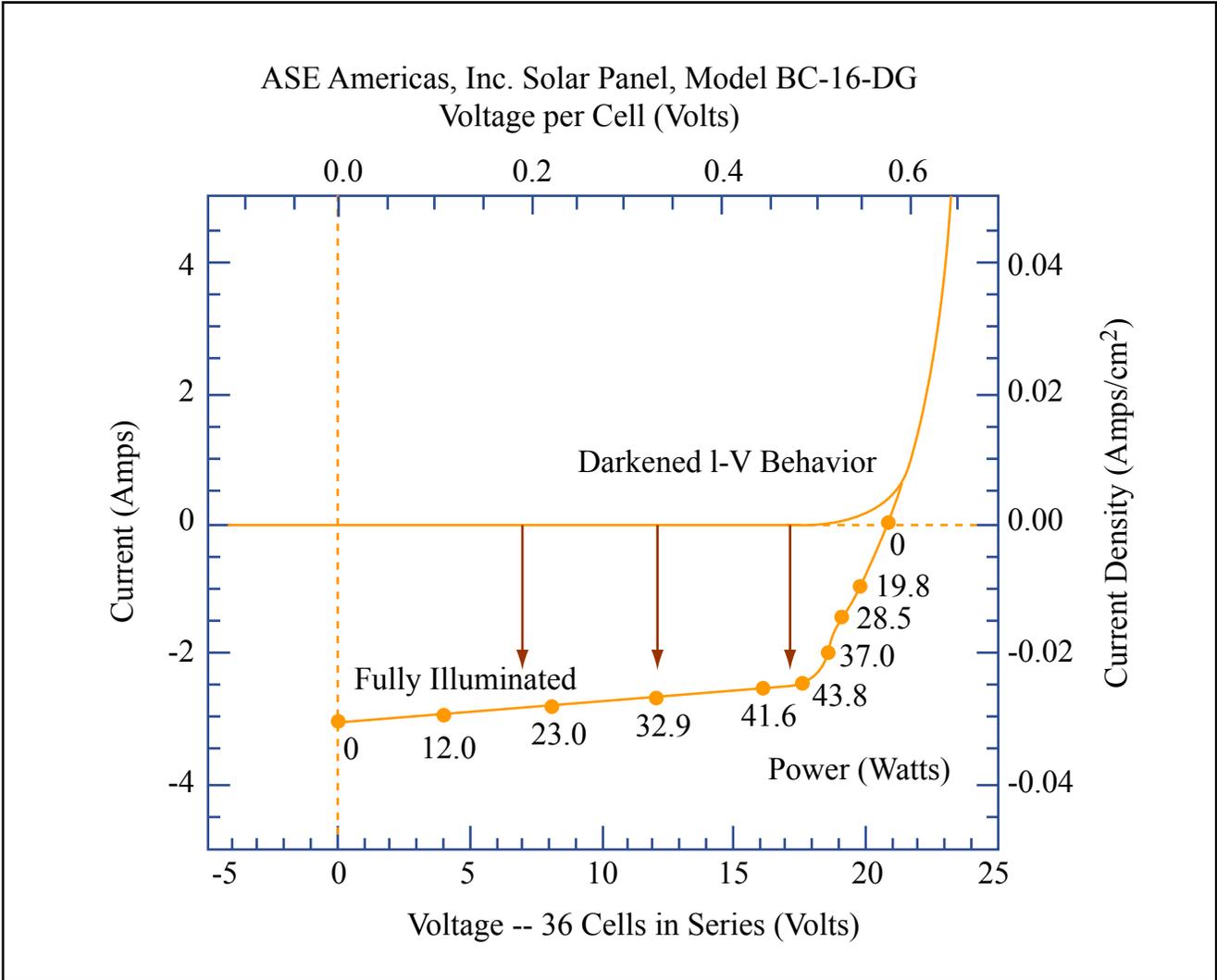


Figure by MIT OCW.